

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE UNITED STA	TES PATENT AND TRADEMARK OFFICE  Reply under 37 CFR 1.116 — Expedited Procedure  Examining Group 2823  09/652,533  August 31, 2000  Gurlej S. Sandhu et al  Micron Technology, Inc.  2823
E (5)	Reply under 37 CFR 1.116 — Expedited Procedure 1, Mulli-
· ·	Examining Group 2823
MARIE	10/1/1/02
Application Serial No	
Filing Date	August 31, 2000
Inventor	Gurtej S. Sandhu et al
Assignee	Micron Technology, Inc.
Group Art Unit	2823
Examiner	W. Brewster
	MI22-1385
Title: Deposition Methods and Apparatuses Providing Surface Activation	

## **RESPONSE TO SEPTEMBER 4, 2002 FINAL OFFICE ACTION**

To:

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**Assistant Commissioner for Patents** 

Washington, D.C. 20231

From:

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## **AMENDMENTS**

## In the Claims

No amendments.

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